## Reexamination 10/768,184 TAKAHASHI, KAZUHIKO Notice of References Cited Examiner Art Unit Page 1 of 1

Application/Control No.

Ly D. Pham 2827

Applicant(s)/Patent Under

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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